MRSI-M3
3-Micron Die Bonder
**Overview**

The MRSI-M3 3-Micron Die Bonder sets the industry standard for ultra-precision, high-complexity die attach in high volume production environments. With features such as force control, ultra precise placements, and 360° die orientation, the MRSI-M3 automated die bonder ensures high yields, high quality and high reliability in advanced packaging.

The highly configurable, MRSI-M3 platform ensures optimum asset protection. The system delivers an unmatched combination of 3-micron accuracy, automation, speed and reliability; in-situ assembly processes such as eutectic die bonding, UV epoxy die attach and flip chip assembly are all possible. The MRSI-M3 3-micron die bonder is ideally suited for manufacturers of photonic packages, microwave modules, IR sensors, MEMS, multi-chip modules, stacked assemblies and hybrid devices.

From small dies to large sensors, the MRSI-M3 3-micron die bonder provides all the capability and flexibility to assemble the most advanced packages, without compromising on manufacturing efficiency, quality and reliability.

**Benefits**

The MRSI-M3 uses an advanced cast composite base, enabling fast and accurate moves with virtually no settling time. The large work envelope enables a wide range of configurations to meet customer requirements.

Advanced functionality equates to significant benefits:

- **High Speed AND High Accuracy** - An advanced axis system driven by brushless DC linear servomotors with linear glass-scale encoder feedback for high speeds and accurate movements.
- **High Machine Efficiency AND High Product Quality** – Built-in internal temperature monitoring ensures consistent placement. Known heat sources, such as motors are designed with gas cooling; ensuring that thermal expansion is kept to a minimum.
- **Optimum Placement Yields** - The system's closed-loop force control enables placement of delicate Gallium Arsenide (GaAs) dies with as little as 10 grams of force. At the other end of the scale, forces up to 2kg are programmable.
- **Flexible Component Supply Options** - Die are picked from waffle pack, Gel-Pak™, wafer, tape and reel and custom trays.
- **Maximum Asset Use** – MRSI-M3 machines are designed to handle a wide range of processes. Epoxy dispensing pumps, epoxy stamping and eutectic bonding with scrub and temperature control, are all configuration options that make the MRSI-M3 3-micron die bonder a complete assembly solution.
**Standard Features - MRSI-M3**

The base 3-Micron Die Bonder comes already equipped with industry-leading functionality. Additional capability is available to reflect specific application needs. Standard Features include:

**Large Work Area**

The MRSI-M3’s large configurable work area holds up to 72 waffle packs; Gel-Paks™, tape feeders, and wafers may also be used. Waffle packs may be loaded from the front and back on easily removable and reloadable sector plates. Waffle pack feeders are easily integrated. Also, waffle pack adapters may be used with the automatic wafer changer. Epoxy stamping, in-situ eutectic, and other custom options can all be accommodated simultaneously in the workspace.

**High Speed Production**

The MRSI-M3 die bonder is designed for high-speed movements AND ultra-precise 3 micron placements. The composite base, low weight gantry, and powerful linear motors are engineered for fast acceleration at submicron resolution. Overall, the system is characterized by an unprecedented level of capability and technology that translates into high value and investment protection. The net result is unrivaled accuracy at high production rates.

**Force Control**

Closed-loop force feedback enables delicate handling of III-V semiconductor components, such as Gallium Arsenide (GaAs) and Indium Phosphide (InP) devices as well as MEMS with fragile microstructures. Die are processed with forces as low as 10 grams applied to the component. Force values are programmed per component type, which means that each die type can be picked and placed with its unique programmed and controlled force.

**Advanced Vision System with 360° Die Orientation**

The MRSI-M3’s advanced vision system enables rapid detection and orientation of die over a full 360°. Boundary trace or pattern recognition is used to locate the die center or application-critical features. Fast and accurate orientation detection enables die such as MMICs and laser diodes to be used directly from the supplier, eliminating the need for pre-orientation. Global and local vision alignment schemes are used for nested substrates and features, enabling fast and error-free processing of complex assemblies. The machine is configured with an upward looking camera that can be used for processing flip chips and other components with bottom features.
Programmable Multi-Color Lighting

Lighting intensity is programmable for both ring and collimated light functions, for each camera. Optimal light conditions may be set for die recognition and for alignment. Multi-color lighting may be used to enable optimum imaging of low-contrast components. Red, green and blue programmable lighting is a powerful tool when processing challenging alignment surfaces such as gold on alumina. Such an advanced vision toolbox ensures optimum performance, which directly translates into less machine interruptions due to vision errors.

MRSI Systems Windows Die Bonder Software

The MRSI-M3's intuitive graphical user interface runs on Windows™ and simplifies the set-up and production process. The software includes a pre-programmed library of wafer pack and die. Additional components are easily taught and are available for all substrate programs. Calibration routines, offline programming, and CAD download mean programming is quick and easy. The MRSI-M3 is the perfect companion to MRSI Systems dispense equipment since it shares the same software user interface.

MRSI-M3 - Configurable Options

MRSI systems may be configured with off-the-shelf options to meet application-specific needs, a cost effective alternative to custom automation. The base platform comes equipped with standard features. The machine can then be configured in various ways with one or a combination of the following options:

1. Material Handling

   Tooling is modular, ensuring fast, easy change-over between production runs.

   The MRSI-M3 supports three modes of operation when it comes to product presentation. They are: in-line conveying, cassette-to-cassette load/unload, or stand alone mode. The system's conveyor readily handles boats, fixture trays, lead frames and boards.

   Benefits:
   - Easily integrated into automated production lines, both the in-line and cassette-to-cassette tooling options allow for greater machine autonomy, translating into a workload reduction and less setup downtime.
   - Standalone tooling allows for greater flexibility required for R&D and small lot production, translating into faster changeover and therefore higher machine efficiency.
   - Existing customer tooling, used upstream and or downstream from the assembly step, can be adapted; allowing streamlined product handling strategies to be implemented. Less product transfer means less operations, lower handling defect rates and improved cycle time.
2. Tool Change

Limitless number of pick-up and stamping tools on board - The MRSI-M3 features a thirteen-position tool bank with fast automatic tool change. Additional tool change banks are added for a wider range of tools. The tool change banks hold round surface pick-up tips, perimeter and inverted pyramid collets, and stamping tools. This is particularly well suited for processes requiring a large number of parts-specific tools, such as eutectic bonding applications.

Benefits:
- Ability to assemble complex products with a multitude of component types. Overall reduction in production cycle time translates into higher throughputs.
- Fast Product Change-Over means increased machine efficiency. Increased efficiency translates into higher output and lower manufacturing costs.

3. Wafer Processing

Direct Pick from Wafers minimizes die handling and simplifies supply chain - The MRSI-M3’s automatic wafer feeder includes automatic theta compensation, servo controlled synchronized closed loop movement of the pick head and the ejection needle, wafer mapping, ink dot detection, and fast change ejection needle clusters. Needleless ejector system is available for ultra-thin devices.

Thin and fragile die are delicately picked from the wafer tape by synchronizing the movement of the pick head and the ejection needles. Automatic theta compensation aligns the die to the needle cluster in the theta axis. Wafer maps or ink dots are supported, ensuring that only the good die are processed. Fast change ejector needles and domes allow for easy accurate changeover between device types.

Benefits:
- By using servo controlled synchronized systems, yield is increased by avoiding damaged and cracked die, especially for thin, fragile III-V material die, with internal or surface features.
- Production volumes are increased by eliminating pick error caused by wafer theta to the ejector pins alignment, especially for high aspect ratio devices.
- Wafer result mapping and ink dot recognition assures only know-good-die are used, thus ensuring a high yield. Fast change ejector needles and domes maximize system uptime.

4. Standalone Eutectic Die Bonding

Flexible and High Throughput Solution for High-Reliability Packages

The MRSI-M3 may be configured with a eutectic bonding kit, ideal for Gold Silicon, Gold Tin and Gold Germanium bonding processes. With this package, applications such as eutectic bonding on sub-mounts, TO headers, and butterfly packages are possible. An optional Progressive Heated Boat Indexer is available for high volume eutectic applications.

Both direct eutectic and reflow eutectic bonding processes are supported. The package includes a reflow station with a hi-speed temperature ramp (closed loop pulse heating). A heated cover gas of Hydrogen and Nitrogen is present
over the hot plate. The reflow station design includes provisions for vacuum hold down or part clamping. The system automatically transports the substrate or package to and from the stage for eutectic bonding.

The eutectic station is programmable, tailoring the process to your specific bonding requirements.

- Contact Forces are closed-loop controlled
- Temperature ramp rates are programmable, optimizing the heating profile while avoiding thermal shock.
- Multiple temperature set points are programmed to bring the substrate to a base temperature, followed by a final rise to the reflow temperature, as the part is placed.
- A programmable mechanical scrub may be used to break through oxide layers, thereby ensuring overall bonding quality.

Benefits:

- This optional package permits a portfolio expansion to offerings of hermetically-sealed packages. In addition to packaging of high power devices such as amplifiers, a path is provided for mass production of photonics/optical assemblies.
- The fully automated process ensures repeatable results, equating to higher yields, and an improved bottom line.
- Programmable fast ramping eutectic stage allows process flexibility, while maximizing throughput. Well controlled cover gas flow and temperature minimizes voiding. Vacuum and mechanical part clamping flexibility eliminates part movement during eutectic bonding. A tightly controlled process ensues. Higher yields and repeatable quality is the outcome.

5. In-Line Eutectic Capability

Fully-Automated Eutectic Die Bonding Reduces Labor Costs, Improves Yields – An automated in-line material handling system is coupled with MRSI’s well proven In-Situ die bonding options to provide a high speed, fully automated turn-key solution for eutectic die attach processes.

- The in-line material handling system loads a carrier of substrates (boat) onto the conveyor. The conveyor transfers the boat to the bonding area.
- Substrates are incrementally heated to the process temperature by processing through preheat zones.
- At the bond station parts come into contact with the pulse heated bonding stage and the eutectic bonding process is performed.
- The boat is then indexed to the next substrate position and the above process is repeated until all the boat positions have been assembled. As the indexer transfers the boat, the packages are incrementally cooled by passing over a cool down zone position. When completed, the indexing conveyor transfers the boat to the output magazine loader.

Various bonding processes are supported:

- For Gold Silicon direct eutectic, the system aligns the package and then picks and places the die, and scrubs (variable amplitude and frequency) to accomplish the eutectic bond. A heated cover gas of Hydrogen and Nitrogen is present over the bonding area.
- For solder reflow eutectic bonding, such as Gold Tin (Au/Sn) eutectic attach of Gallium Arsenide (GaAs) and Gallium Nitride (GaN) die, the system aligns the package and picks and places a preform onto the package (if required, the preform can be pre-deposited). The die is then picked and placed, while the temperature at the bonding position is ramped using a pulse-heated eutectic stage and scrubbed (variable amplitude and frequency) to accomplish the eutectic reflow. A heated cover gas of Hydrogen and Nitrogen is also present over the bonding area.
Benefits:
  • Improved productivity through automation. Scalable to high volumes.
  • Expanded portfolio, as capability is extended to high-power semiconductor packages requiring high heat dissipation rates.
  • Investment protection if re-configuration becomes necessary. Machine retains its base modular nature.

6. In-situ UV Epoxy Dispensing & Curing

Controlled End Accuracy by In-Situ Curing – Applications such as the assembly of Active Optical Cables (AOCs) cannot tolerate loss in die placement accuracy during the post-placement epoxy curing operation. Lenses, for example, require extremely accurate post die bond positioning to ensure optimum system performance. In such cases, In Situ UV epoxy curing is a solution, whereby parts are cured while held in place, eliminating the possibility of components moving as the epoxy material cures.

The UV option includes specialized UV epoxy dispense hardware, as well as curing accessories. This includes easy-clean, accurate time/pressure dispense pumps for short pot-life materials.

Auto-shutter light guards on the dispense needles ensure that the dispense needle tips do not clog due to inadvertent UV exposure.

Benefits:
  • Provides advanced assembly capability on a flexible platform base.
  • Fully automated process ensures high yields and reduced labor costs.

7. Dispense Capability

Dispense AND Place on the same machine - The MRSI-M3 open platform may be configured with dual cartridge style positive displacement dispensing pumps, thereby complementing its core assembly capabilities. Thus, a single machine is able to handle the dispensing of die attach, dam and fill material or lid attach material; followed by the placement of the die or lid as part of a single process setup. The complete assembly process on a single platform is enabled. The addition of dispensing pumps on the MRSI-M3 provides precise control of epoxy volume when dispensing small dots or area fills. Main features include:

  • Closed loop servo motors
  • A three-point laser height sensor provides the ability to
determines the tilt of each surface on which material will be dispensed.
  • Automatic needle cleaning
  • Automatic needle alignment enables fast setup and switching between pattern types.
  • Automatic software calibration routine using through beam sensors
  • Automatic priming
  • Line drawing capability
  • Superior bond line thickness control

Benefits:
  • Avoid the purchase of a separate dispensing machine. Ideal for R&D environments, prototyping and low volume production.
  • Minimize floor space
• Reduced setup time
• Scale up with a MRSI-175Ag when volumes ramp. No need to re-qualify.
• Investment protection through ability to reconfigure the base platform.

8. Epoxy Stamping

Complex Assemblies on ONE Platform, with multiple epoxy materials and multiple die sizes along with placement - A rotating stamping-well with multiple epoxy grooves presents epoxy for stamping. Dot size is determined by the depth of the groove and tip dimensions.

Stamping (or daubing) tools are interchangeable with standard pickup tools and are used to create very small epoxy dots by touching down in the stamping well and then onto the substrate. Single dots as small as 0.004” (100 microns) are possible. They may also be ganged for higher throughput.

Benefits:
• Portfolio expansion - Added capability of small die processing, multi-chip modules.
• Solution for die attach of small die
• Solution for die attach of complex module assembly with die of varying sizes and varying epoxy materials.
• Minimize floor space
• Reduced setup time
• Investment protection through ability to reconfigure the base platform

Multiple epoxies with multiple stamping tools enable stamping of a large variety of materials and dot sizes.
Turnkey Integrated Production Lines

MRSI Systems offers a complete solution for advanced packaging, including our family of high-speed precision die bonders and epoxy dispensers. SMEMA compatibility allows integration of our systems with a wide range of compatible process equipment such as in-line ovens for a turnkey solution. MRSI’s reliable systems combined with our worldwide service and support commitment means your system will always be available for production.

### Specifications

<table>
<thead>
<tr>
<th>Applications</th>
<th>Microwave modules, hybrids, optical modules, epoxy and eutectic die attach</th>
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</thead>
<tbody>
<tr>
<td>Smallest Die</td>
<td>0.008 inches square (200 microns square)</td>
</tr>
<tr>
<td>Placement Accuracy</td>
<td>3 micron, 3 sigma, true radial position (application dependent)</td>
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<tr>
<td>Placement Repeatability</td>
<td>≤ 1 micron</td>
</tr>
<tr>
<td>Z Axis Accuracy</td>
<td>Place to force or height</td>
</tr>
<tr>
<td>XY Motors</td>
<td>Brushless DC linear motors with 50 nm resolution glass scale encoders</td>
</tr>
<tr>
<td>X Travel</td>
<td>17.5 inches (444.5 mm)</td>
</tr>
<tr>
<td>Y Travel</td>
<td>36.0 inches (914.4 mm)</td>
</tr>
<tr>
<td>Z Travel</td>
<td>1.5 inches (38.1 mm)</td>
</tr>
<tr>
<td>Θ Travel</td>
<td>360º</td>
</tr>
<tr>
<td>Θ Resolution</td>
<td>0.0045º</td>
</tr>
<tr>
<td>Force Control</td>
<td>Programmable per placement - 10 grams to 5 Kg</td>
</tr>
<tr>
<td>Cameras</td>
<td>2 down looking with one shared optical path - 1 up looking</td>
</tr>
<tr>
<td>Vision System</td>
<td>Edge detection and pattern recognition</td>
</tr>
<tr>
<td>Lighting</td>
<td>Red, green and blue; ring or collimated; programmable intensity</td>
</tr>
<tr>
<td>Pickup Tips</td>
<td>13 tips in standard tip change bank; multiple banks are optional; also holds stamping tips</td>
</tr>
<tr>
<td>Collets</td>
<td>Perimeter collets, inverted pyramid collets, plus custom</td>
</tr>
<tr>
<td>Waffle Packs</td>
<td>Up to 72 x 2 x 2 inch waffle (50.8 x 50.8 mm) or Gel-Paks™ or 4 x 4 inch (101.6 x 101.6) Up to ten 8 mm tape and reel feeders</td>
</tr>
<tr>
<td>Tape and Reel</td>
<td></td>
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<tr>
<td>Eutectic Bonding</td>
<td>Programmable ramp rates up to 450°C</td>
</tr>
<tr>
<td>Forming Gas</td>
<td>Nitrogen, Argon or N2-H2 or Ar-H2</td>
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<tr>
<td>Scrub</td>
<td>Programmable plus library of customizable scrub motions</td>
</tr>
<tr>
<td>Dispense Pumps</td>
<td>2 cartridge style, rotary, positive displacement pumps or time/pressure</td>
</tr>
<tr>
<td>Height Sensing (dispense)</td>
<td>3 point laser height mapping of substrate plane</td>
</tr>
<tr>
<td>Dispense Needle Clean</td>
<td>Automatic, programmable occurrence between dispense patterns</td>
</tr>
<tr>
<td>Cleanroom Compatibility</td>
<td>Various options available</td>
</tr>
<tr>
<td>Dispense Needle Calibration</td>
<td>Automatic software calibration routine using through beam sensors</td>
</tr>
<tr>
<td>Heated Bonding Head (Optional)</td>
<td>Provides maximum head transfer from atop devices in conjunction with traditional heating beneath devices within a low oxygen atmosphere. Up to 400°C at steady status or pulsed conditions. Provides an effective means to ensure accurate and reliable die bonding when a high level of parallelism (co-planarity) between two bonding surfaces is required. The challenges of the bonding co-planarity could result from large size of a die, a die with a high aspect ratio between length and width, the wedge effect along thickness of a die and/or a carrier, etc. MRSI Systems' production-ready and time-proven technology compensates for these conditions and enables optimal device attachment, be it electrical interconnects or optical paths. Innovative in design, Die Bonding with Co-planarity Adjustment supports a wide variety of applications satisfying Optical Communications, Industrial Lasers, LiDAR, Aerospace, Medical, and more.</td>
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MRSI Systems LLC
101 Billerica Ave. Bldg 3 North
Billerica, MA 01862-1256
Tel 978-667-9449
Fax 978-667-6109
www.mrsisystems.com

MRSI Systems, part of Mycronic Group, is the leading manufacturer of fully automated, high-speed, high-precision and flexible eutectic and epoxy die bonding systems. We offer "one-stop-shop" solutions for research and development, low-to-medium volume production, and high volume manufacturing of photonic devices such as lasers, detectors, modulators, AOCs, WDM/EML TO-Cans, Optical transceivers, LiDAR, VR/AR, sensors, and optical imaging products. With 30+ years of industry experience and our worldwide local technical support team, we provide the most effective systems and assembly solutions for all packaging levels including chip-on-wafer (CoW), chip-on- carrier (CoC), PCB, and gold-box packaging. For more information visit www.mrsisystems.com.